

Search Notes 	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/626,657	TSENG
	Examiner	Art Unit
	Michael A. Friedhofer	2832

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
200	543-546	2/18/2005	MAF
200	537,51.15	2/18/2005	MAF
200	11a,413	2/18/2005	MAF
200/420,331		2/18/2005	MAF